



FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEINFORMATION DISCLOSURE
STATEMENT BY APPLICANTSATTY. DOCKET NO.
VAW-7APPLICATION NO.
10/053,773APPLICANTS
Günter Schubert et al.CONFIRMATION NO.
4264FILING DATE
January 22, 2002GROUP ART UNIT
3626

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER INITIAL	
<i>SPK</i>	P. Meka and F.C. Stehling, "Heat Sealing of Semicrystalline Polymer Films. I. Calculation and Measurement of Interfacial Temperatures: Effect of Process Variables on Seal Properties," <u>Journal of Applied Polymer Science</u> , Vol. 51, No. 1 at 89-103 (January 3, 1994).

EXAMINER

*SPK*DATE CONSIDERED *4-6-2003*

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not conformance and not considered. Include copy of this form with next communication to applicants.